

Supporting Information for:

Creation of liquid-crystal periodic zigzags by surface treatment and thermal annealing

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Figure S1

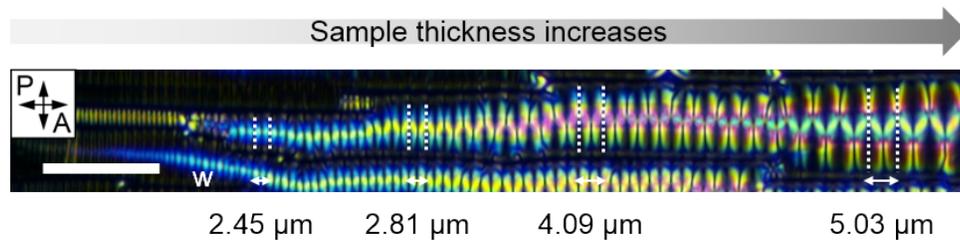


Fig. S1 DRLM images of the zigzag structures as increasing sample thickness. The scale bar is 20 μm .

Figure S2

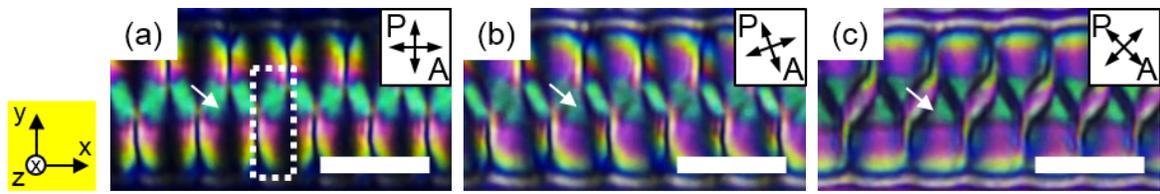


Fig. S2 DRLM images of the zigzag structure as rotating crossed polarizers at (a) 0° , (b) 20° , and (c) 45° .

The scale bar is $10\ \mu\text{m}$.

Figure S3

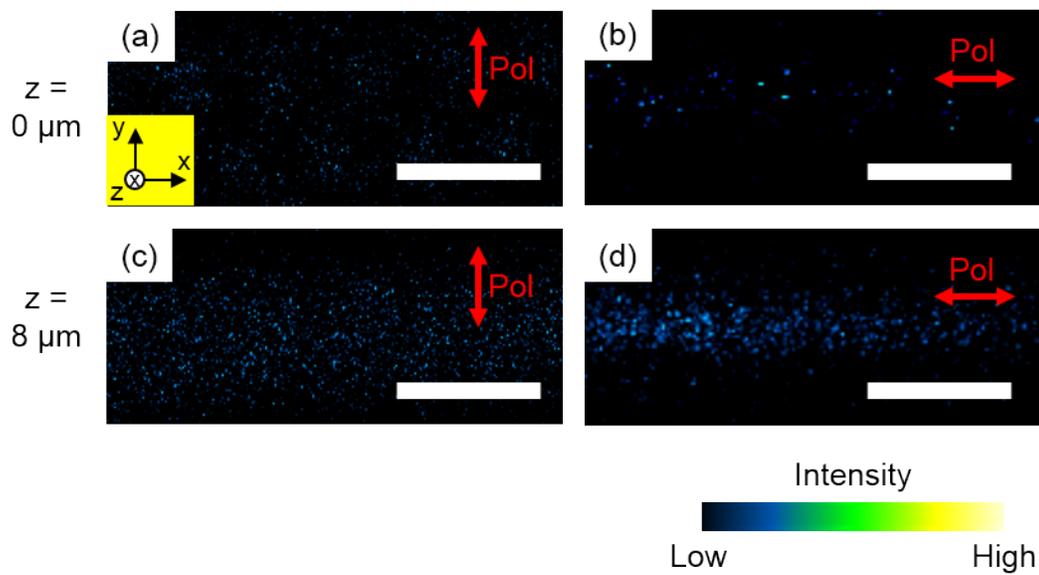


Fig. S3 The fluorescent intensities in LSFCM images at (a and b) $z = 0 \mu\text{m}$ and (c and d) $z = 8 \mu\text{m}$. The scale bar is $10 \mu\text{m}$.

Figure S4

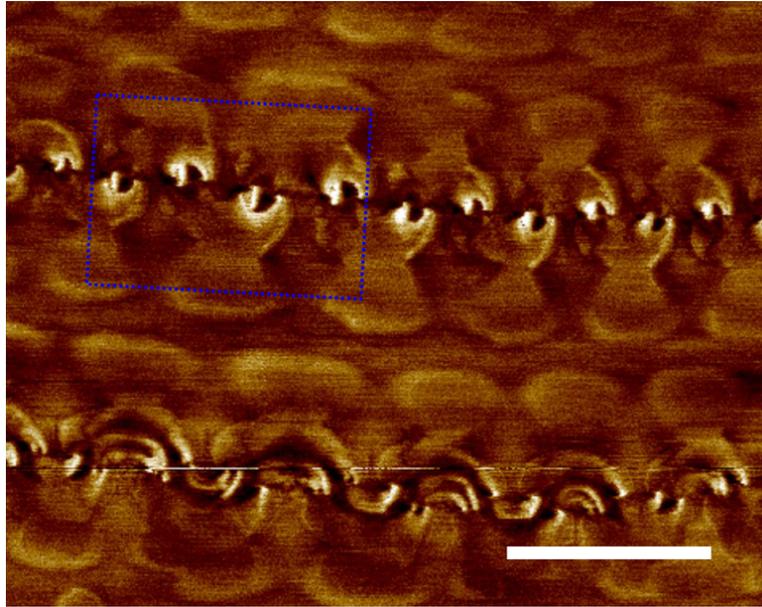


Fig. S4 The AFM phase image of the zigzag structure. The blue box is the same area shown in the Figure 4(a). The scale bare is 10 μm .

Figure S5

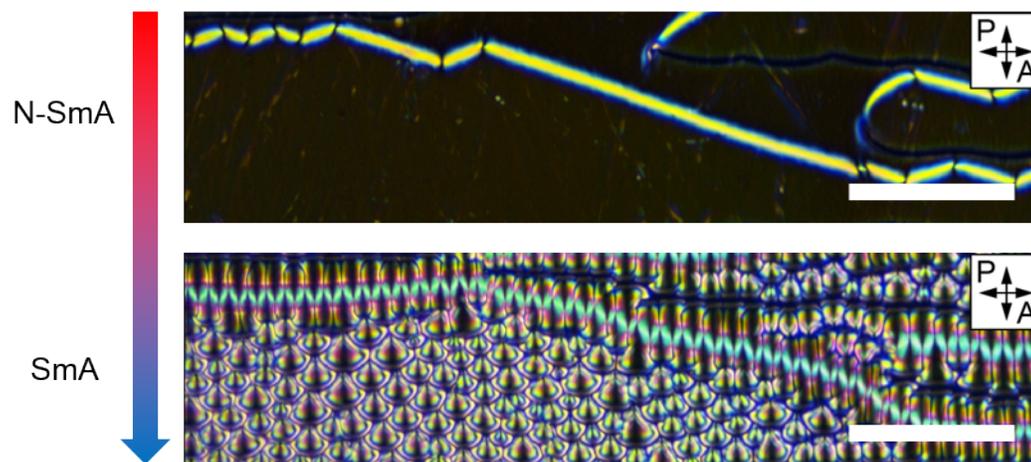


Fig. S5 Structural transition behaviour of the zigzag disclination lines upon cooling from N-SmA transition to SmA phase. The scale bare is 50 μm .

Figure S6

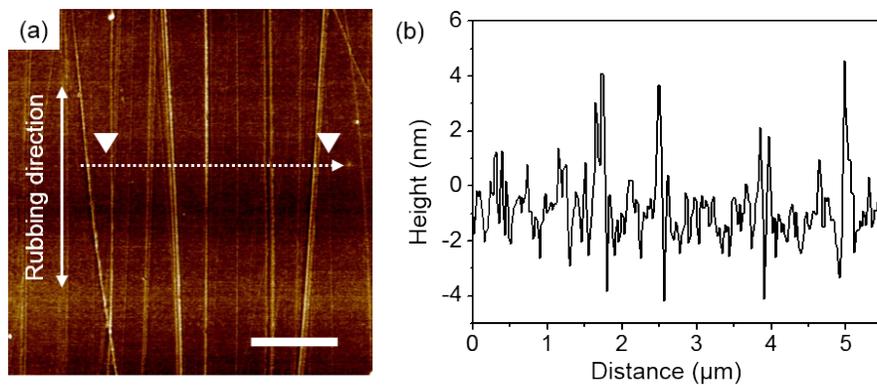


Fig. S6 A AFM study of the rubbed PI-coated Si substrate. (a) The AFM topographic image of the rubbed PI-coated Si substrate and (b) its height profile. The scale bare is 2 μm .